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Notice of Allowability	Application No.	Applicant(s)	
	10/663,614	MAHANPOUR ET AL.	
	Examiner	Art Unit	
	Hsien-ming Lee	2823	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate commu IGHTS. This application is so	this application. If not included nication will be mailed in due course. TH	
1. This communication is responsive to 4/11/2005.			
2. The allowed claim(s) is/are 1-22.			
3. \boxtimes The drawings filed on <u>09 February 2004</u> are accepted by t	he Examiner.		
4. Acknowledgment is made of a claim for foreign priority unall All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be subminsFORMAL PATENT APPLICATION (PTO-152) which giv 6. CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner' Paper No./Mail Date ldentifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the deposit of the proper No./Mail Date ldentifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the deposit of the proper No./Mail Date ldentifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the deposit of the priority documents and the deposit of the priority documents and the priority documents and the priority documents and the priority documents have a priority document and the priority documents have a priority documents have a priority document and the priority d	e been received. e been received in Application cuments have been received of this communication to file MENT of this application. Initted. Note the attached EXA es reason(s) why the oath or set be submitted. Son's Patent Drawing Review as Amendment / Comment or .84(c)) should be written on the header according to 37 CFF isit of BIOLOGICAL MATE	in No in this national stage application from the reply complying with the requirements MINER'S AMENDMENT or NOTICE OF declaration is deficient. (PTO-948) attached in the Office action of the drawings in the front (not the back) of the 1.121(d). RIAL must be submitted. Note the	
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948) 3. Information Disclosure Statements (PTO-1449 or PTO/SB/C Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Su Paper No./I 08), 7. ☑ Examiner's /	ormal Patent Application (PTO-152) mmary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allowance . HSIEN-MING LEE PRIMARY EXAMINED	

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DETAILED ACTION

Remarks

1. The objection to the specification, as set forth in the previous Office action, is withdrawn in response to applicant's amendment filed 4/11/2005.

Examiner's Amendment

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Robert A. Voigt, Jr. (Reg. No. 47,159) on June 7, 2005.

The application has been amended as follows:

On page 7 of the original filed specification, at line 9, replace "104A-B" with – 104A-104B --

In claim 1 (line 10), claim 15 (line 2) and claim 22 (line 10), insert – second and third – after "etched."

In claim 3 (line 2), claim 12 (line 2) and claim 18 (line 2), replace "bright" after "appearing" with -- brighter than areas in which there is not a conductive path --.

Allowable Subject Matter

- 4. Claims 1-22 are allowed.
- 5. The following is an examiner's statement of reasons for allowance: see the reasons in the previous Office action.

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Any comments considered necessary by applicant must be submitted no later than the 6.

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Any inquiry concerning this communication or earlier communications from the 7.

examiner should be directed to Hsien-ming Lee whose telephone number is 571-272-1863. The

examiner can normally be reached on Tuesday-Thursday ($8:00 \sim 6:00$).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Olik Chaudhuri can be reached on 571-272-1855. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Hsien-ming Lee Primary Examiner

Art Unit 2823

June 7, 2005

HSIEN-MING LEE PRIMARY EXAMINEDE